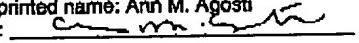


Application No.: 09/639,636

RD25905-6

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Typed or printed name: Ann M. Agosti
Signature: 

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Guida et al. : Group Art Unit: 1722
Application No. 09/639,636 : Examiner: Luk, Emmanuel S.
Filed: 15 August 2000 : Response to Paper No. 5
For High Resolution Anti-Scatter X-ray
Grid and Laser Fabrication Method

AMENDMENT UNDER 37 CFR 1.111

Assistant Commissioner for Patents
Washington, DC 20231

In response to the Office Action dated 21 November 2002, please amend the above-identified application by amending the title, canceling claims 1-9, and amending claims 15-17 as indicated in the Listing of Claims.

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5183877751 TO 817038729310 P.02/09

Application No.: 09/639,636

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LISTING OF REPLACEMENT TITLE

System for Fabricating High Resolution Anti-Scatter X-ray Grid and Laser Fabrication Method